

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **ISHIKAWA, Mitsunori, et al.**

Group Art Unit: **1716**

Serial No.: **10/589,490**

Examiner: **CROWELL, Anna M.**

Filed: **May 22, 2007**

P.T.O. Confirmation No.: **8238**

For: **SEMICONDUCTOR MANUFACTURING DEVICE AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICES**

RESPONSE UNDER 37 CFR §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 1716

MAILSTOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 19, 2011

Sir:

In response to the Office Action dated January 20, 2011, entry of the following amendments and remarks, further examination, and reconsideration are respectfully requested.

Amendments to the Claims are reflected in the listing of claims which begins on page two of this paper.

Remarks/Arguments begin on page four of this paper.